



**ELECTRONIC COPY**

LG770625193  
Report verification at igi.org



February 19, 2026

IGI Report Number **LG770625193**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **10.10 - 10.14 X 6.31 MM**

**GRADING RESULTS**

Carat Weight **4.06 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

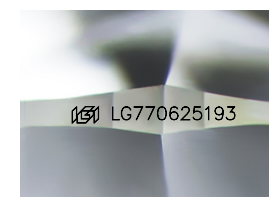
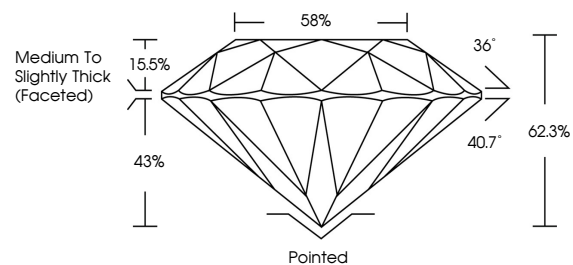
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG770625193**

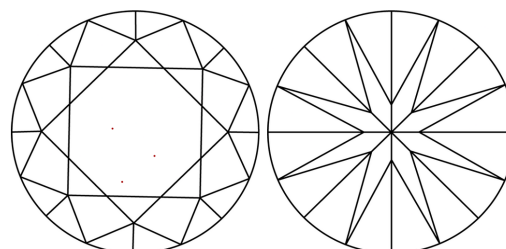
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

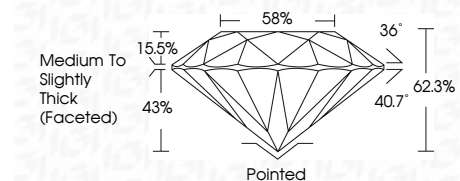
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



February 19, 2026  
IGI Report No LG770625193  
**ROUND BRILLIANT**

**4.06 CARATS**  
F

**10.10 - 10.14 X 6.31 MM**  
VVS 2  
IDEAL  
62.3%  
58%  
Medium To Slightly Thick (Faceted)

Pointed  
EXCELLENT  
EXCELLENT  
NONE  
NONE  
IGI LG770625193

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

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